



Title	Epitaxial Mn <sub>2</sub> VAL films with L2 <sub>1</sub> -ordered structure for all-Heusler stacks
Author(s)	Yamada, Shinya; Kudo, Kohei; Sadakari, Ryosuke et al.
Citation	Journal of Magnetism and Magnetic Materials. 2022, 561, p. 169644
Version Type	AM
URL	<a href="https://hdl.handle.net/11094/89443">https://hdl.handle.net/11094/89443</a>
rights	©2022. This manuscript version is made available under the Creative Commons Attribution-NonCommercial-NoDerivatives 4.0 International License.
Note	

*The University of Osaka Institutional Knowledge Archive : OUKA*

<https://ir.library.osaka-u.ac.jp/>

The University of Osaka

# Epitaxial Mn<sub>2</sub>VAI films with $L2_1$ -ordered structure for all-Heusler stacks

Shinya Yamada<sup>a,b</sup>, Kohei Kudo<sup>b</sup>, Ryosuke Sadakari<sup>b</sup>, Kohei Hamaya<sup>a,b</sup>

<sup>a</sup>*Center for Spintronics Research Network, Osaka University, Toyonaka, Osaka 560-8531, Japan*

<sup>b</sup>*Graduate School of Engineering Science, Osaka University, Toyonaka, Osaka 560-8531, Japan*

---

## Abstract

The structural and magnetic properties of epitaxial Mn<sub>2</sub>VAI films grown by molecular beam epitaxy are investigated. Epitaxial Mn<sub>2</sub>VAI films with a relatively high  $L2_1$ -ordering of  $\sim 0.7$  are obtained on MgO(001) substrates at a growth temperature of 350 °C. The saturation magnetic moment at 300 K for the epitaxial Mn<sub>2</sub>VAI films is  $\sim 1.2 \mu_B/\text{f.u.}$ , which is almost equivalent to the highest value for high-temperature-grown thin-film samples reported previously. Due to the low-temperature synthesis of  $L2_1$ -Mn<sub>2</sub>VAI, an epitaxial all-Heusler  $L2_1$ -Mn<sub>2</sub>VAI/ $L2_1$ -Fe<sub>2</sub>VAI/ $L2_1$ -Mn<sub>2</sub>VAI trilayer with sharp heterointerfaces is obtained. This study presents the possibility of all-Heusler current-perpendicular-to-plane giant magnetoresistive devices with high performance.

*Keywords:* Heusler alloy, Mn<sub>2</sub>VAI, Epitaxial films, Molecular beam epitaxy

---

## 1. Introduction

Full-Heusler alloys with a chemical formula of  $X_2YZ$  ( $X$ ,  $Y$ : transition metals;  $Z$ : a main group element) have been widely studied because of their potential for various functionalities[1–3]. In particular, half-metallic full-Heusler alloys have been explored as ferromagnetic electrodes for the tunneling magnetoresistance effect[4, 5], the current-perpendicular-to-plane giant magnetoresistance (CPP-GMR) effect[6, 7], and spin injection into semiconductors[8–12].

Among the full-Heusler alloys with a half-metallic nature and a high Curie

temperature, a ferrimagnetic Heusler alloy,  $\text{Mn}_2\text{VAl}$ [13, 14], has been focused on as a potential spintronic material. The Mn and V atoms in  $L_{21}$ -ordered  $\text{Mn}_2\text{VAl}$  are antiferromagnetically coupled (Mn:  $1.413 \mu_B/\text{f.u.}$ ; V:  $-0.786 \mu_B/\text{f.u.}$ )[14]. Therefore,  $\text{Mn}_2\text{VAl}$  has a small magnetic moment ( $\sim 2 \mu_B/\text{f.u.}$ )[14] compared with well-known half-metallic full-Heusler alloys such as  $\text{Co}_2\text{MnSi}$  ( $\sim 5 \mu_B/\text{f.u.}$ )[15] and  $\text{Co}_2\text{FeSi}$  ( $\sim 6 \mu_B/\text{f.u.}$ )[16]. Because the critical current density required to switch the magnetization through the spin-transfer torque is proportional to the product of the saturation magnetization ( $M_S$ )[17], the use of  $L_{21}$ -ordered  $\text{Mn}_2\text{VAl}$  as a ferromagnetic electrode in spintronic devices has an advantage in terms of low-power-consumption magnetization switching. In addition,  $L_{21}$ -ordered  $\text{Mn}_2\text{VAl}$  shows a high Curie temperature of 760 K in the bulk[18], which is suitable for practical applications. Furthermore, a theoretical study has proposed that  $\text{Mn}_2\text{VAl}/\text{Fe}_2\text{VAl}/\text{Mn}_2\text{VAl}$  all-Heusler-based CPP-GMR junctions would exhibit a significantly large output due to the band symmetry and Fermi surface matching[19]. Therefore,  $\text{Mn}_2\text{VAl}$  has significant potential as a spintronic material in terms of device applications.

Many experimental studies on  $\text{Mn}_2\text{VAl}$  have been reported for the bulk[18, 20–25] and thin films[26–32]. A high degree of  $L_{21}$ -ordering ( $S_{L_{21}}$ ) of  $\sim 0.84$  and an almost theoretical  $M_S$  value of  $\sim 1.82 \mu_B/\text{f.u.}$  at 5 K were reported for bulk samples[25]. In contrast, the values of  $S_{L_{21}}$  and  $M_S$  for thin-film samples were much smaller than those for the bulk samples[26–28]. Relatively high  $S_{L_{21}}$  and  $M_S$  values were recently reported for thin-film samples[29, 30]. However, a high growth temperature ( $T_g$ ) above 500 °C is generally required to obtain  $L_{21}$ -ordered  $\text{Mn}_2\text{VAl}$  films[26–30, 32]. Since such a high  $T_g$  can easily induce atomic interdiffusion in spintronic devices, there are some limitations to its applications such as the all-Heusler-based CPP-GMR devices.

We have developed techniques for the growth of some full-Heusler alloys by low-temperature molecular beam epitaxy (MBE). Unlike most thin-film studies on full-Heusler alloys, relatively high degrees of structural ordering have been obtained at less than 350 °C[10, 12, 33–44]. These low-temperature MBE techniques have also enabled all-Heusler stacks with sharp heterointerfaces[45, 46].

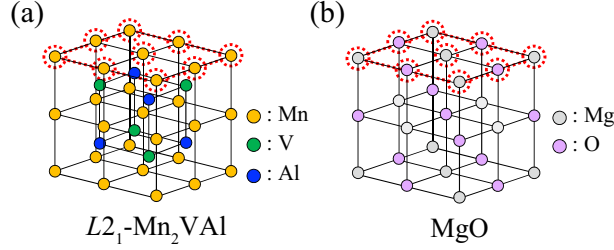


Figure 1: (Color online) Schematics of crystal structure and atomic arrangements of the (001) plane for (a)  $L_{21}$ -ordered  $Mn_2VAl$  and (b)  $MgO$ .

If the low-temperature synthesis of  $L_{21}$ -ordered  $Mn_2VAl$  can be achieved, then various spintronic applications can be expected.

In this paper, we study the structural and magnetic properties of epitaxial  $Mn_2VAl$  films grown by MBE. Epitaxial  $Mn_2VAl$  films with a relatively high  $S_{L_{21}}$  of  $\sim 0.7$  are obtained on  $MgO(001)$  substrates at a  $T_g$  of 350 °C. The value of  $M_S$  at 300 K for the epitaxial  $Mn_2VAl$  films is  $\sim 1.2 \mu_B/\text{f.u.}$ , which is almost equivalent to the highest value for high-temperature-grown thin-film samples reported previously[29]. Due to the low-temperature synthesis of  $L_{21}$ - $Mn_2VAl$ , an epitaxial all-Heusler  $L_{21}$ - $Mn_2VAl/L_{21}$ - $Fe_2VAl/L_{21}$ - $Mn_2VAl$  trilayer with sharp heterointerfaces is obtained.

## 2. Experimental methods

Before investigating the crystal growth, we explain the crystal structures of  $Mn_2VAl$  and  $MgO$ , which are illustrated in Figs. 1(a) and 1(b), respectively. The mismatch between the lattice constant of  $Mn_2VAl$  (0.587 nm) and the diagonal length of the lattice constant of  $MgO$  ( $\sqrt{2} \times 0.422 \text{ nm} = 0.597 \text{ nm}$ ) is  $\sim 1.7\%$ . The atomic arrangement in the (001) plane between  $Mn_2VAl$  and  $MgO$  is matched, as shown by the dotted lines in Figs. 1(a) and 1(b). Therefore, an epitaxial relationship of  $Mn_2VAl[100](001)//MgO[110](001)$  can be expected.

$Mn_2VAl$  films were grown on  $MgO(001)$  substrates by MBE[41, 47]. After heat treatment was performed at 500 °C for 1 h, good flatness of the  $MgO(001)$

surface was confirmed by in situ reflection high-energy electron diffraction (RHEED) observations[41, 47]. Cooling the substrate temperature to 100 or 350 °C,  $\text{Mn}_2\text{VAl}$  films with a thickness of  $\sim 25$  nm were grown by co-evaporating Mn, V, and Al using Knudsen cells. Here we set the atomic composition ratio of Mn:V:Al to 2:1.2:2 during growth because the stoichiometric deposition causes deviation of the film composition from stoichiometry under the MBE conditions employed. Structural characterization was conducted using in situ RHEED observations, X-ray diffraction (XRD), high-angle annular dark-field scanning transmission electron microscopy (HAADF-STEM), and energy-dispersive X-ray spectroscopy (EDX) measurements. Magnetic properties were measured with a vibrating sample magnetometer in a physical property measurement system (Quantum Design).

### 3. Results and discussion

Figures 2(a) and 2(b) show in situ RHEED images of  $\text{Mn}_2\text{VAl}$  films grown at 100 and 350 °C, respectively. Symmetrical streaks, which indicate two-dimensional epitaxial growth, are observed for both samples. In particular, for the sample grown at 350 °C, half-order streaks are observed in the RHEED image (yellow arrows), which indicates the formation of the  $L2_1$ -ordered structure.

Figure 2(c) shows XRD profiles by  $\omega$ - $2\theta$  scan for the  $\text{Mn}_2\text{VAl}$  films. 004 diffraction peaks of  $\text{Mn}_2\text{VAl}$  are observed for both samples, which indicates the formation of (001)-oriented epitaxial  $\text{Mn}_2\text{VAl}$  films. The values of the lattice constant estimated from the XRD data for the samples grown at 100 and 350 °C were 0.588 and 0.587 nm, respectively, which are equivalent to those for bulk[18] and thin-film[26, 28–30] samples reported previously. For the sample grown at 350 °C, 002 superlattice diffraction of  $\text{Mn}_2\text{VAl}$  due to the presence of a  $B2$ -ordered structure is observed. In contrast, for the sample grown at 100 °C, only the 004 diffraction peak of  $\text{Mn}_2\text{VAl}$  is observed, which indicates that this  $\text{Mn}_2\text{VAl}$  film forms an  $A2$  structure. From  $\phi$ -scan measurements of the

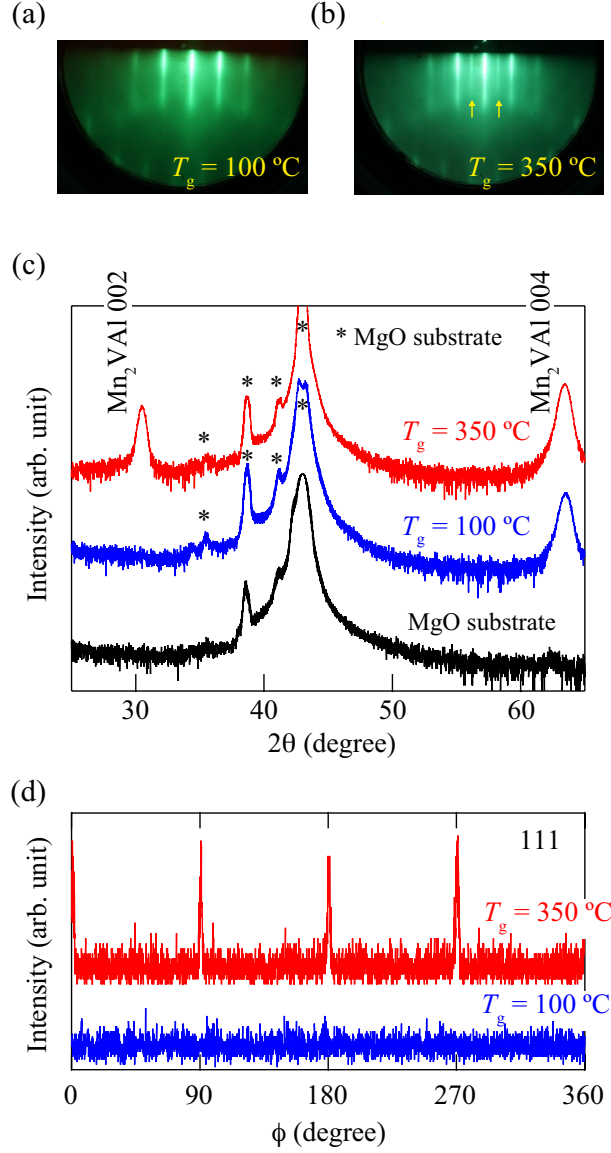


Figure 2: (Color online) RHEED images of  $\text{Mn}_2\text{VAl}$  films grown at (a) 100 and (b) 350  $^\circ\text{C}$ . (c) XRD profiles by  $\omega$ - $2\theta$  scan for  $\text{Mn}_2\text{VAl}$  films, together with that for a  $\text{MgO}(001)$  substrate. (d) XRD  $\phi$ -scan measurement of the (111) plane for  $\text{Mn}_2\text{VAl}$  films.

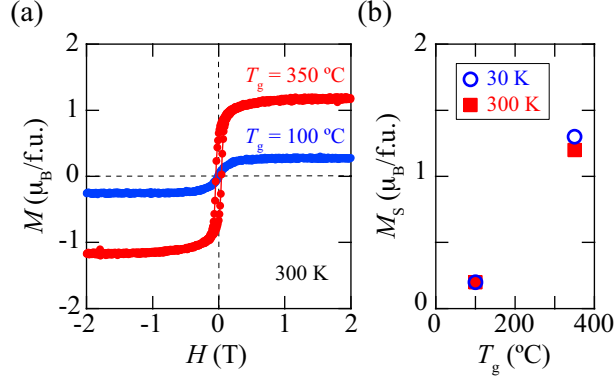


Figure 3: (Color online) (a) In-plane  $M$ - $H$  curves measured at 300 K and (b)  $M_S$  versus  $T_g$  for the  $Mn_2VAl$  films.

(202) plane for the  $Mn_2VAl$  layer and the  $MgO$  substrate (not shown here), we confirmed an in-plane crystal orientation of  $Mn_2VAl[100](001)//MgO[110](001)$  for both samples. The  $\phi$ -scan measurements of the (111) plane are shown in Fig. 2(d). Sharp diffraction peaks with fourfold symmetry are observed only for the sample grown at  $350^\circ C$ , which indicates the presence of the  $L_{21}$ -ordered structure in the film. The degree of  $B2$  and  $L_{21}$  ordering,  $S_{B2}$  and  $S_{L_{21}}$ , is estimated from the XRD data for the  $Mn_2VAl$  film grown at  $350^\circ C$  using the following equations [48, 49],

$$S_{B2} = \sqrt{\frac{I_{002}/I_{004}}{I_{002}^R/I_{004}^R}}, \quad S_{L_{21}} = \frac{2}{3 - S_{B2}} \sqrt{\frac{I_{111}/I_{202}}{I_{111}^R/I_{202}^R}}, \quad (1)$$

where  $I_{hkl}$  and  $I_{hkl}^R$  are the experimental and theoretical peak intensities for the  $hkl$  plane, respectively. The values of  $S_{B2}$  and  $S_{L_{21}}$  were thus estimated to be  $\sim 1$  and  $\sim 0.7$ , respectively. Although the  $T_g$  of  $350^\circ C$  in this study is lower than those reported in previous thin-film studies[26, 28, 29], a relatively high  $S_{L_{21}}$  value is obtained. In addition, the value of  $S_{B2}$  for the film grown at  $350^\circ C$  is  $\sim 1$ , which indicates that  $B2$ -type disorder is suppressed under the MBE growth conditions.

Figure 3(a) shows in-plane field-dependent magnetization ( $M$ - $H$  curves) at 300 K for the  $Mn_2VAl$  films, where the magnetic field was applied along [110]

Table 1: Comparison of  $S_{L2_1}$  and  $M_S$  for bulk and thin-film  $\text{Mn}_2\text{VAl}$ . [25, 26, 28–30]

Sample	Method	$S_{L2_1}$	$M_S$ ( $\mu_B/\text{f.u.}$ )
Poly-crystalline bulk[25]	Arc melting (1200 °C)	$\sim 0.84$	$\sim 1.82$ (5 K)
Epitaxial film[26]	Sputtering ( $T_g = 500$ °C)	$\sim 0.5$ ( $S_{B2} \sim 0.5$ )	$\sim 0.81$ (10 K), $\sim 0.54$ (300 K)
Epitaxial film[28]	Sputtering ( $T_g = 700$ °C)	$\sim 0.4$ ( $S_{B2} \sim 0.7$ )	$\sim 0.88$ (20 K)
Epitaxial film[29]	Sputtering ( $T_g = 600$ °C)	$\sim 0.77$ ( $S_{B2} \sim 0.79$ )	$\sim 1.3$ (300 K)
Epitaxial film[30]	Sputtering ( $T_g = 600$ °C)	$\sim 0.66$ ( $S_{B2} \sim 0.74$ )	$\sim 1.2$ (300 K)
Epitaxial film (This work)	MBE ( $T_g = 350$ °C)	$\sim 0.7$ ( $S_{B2} \sim 1$ )	$\sim 1.3$ (30 K), $\sim 1.2$ (300 K)

direction of  $\text{Mn}_2\text{VAl}$ . The value of  $M_S$  at 300 K for the sample grown at 350 °C is estimated to be  $\sim 1.2 \mu_B/\text{f.u.}$ , which is comparable to those for high-temperature-grown thin-film samples[29]. The coercivity of  $\sim 40$  mT is equivalent to those for the high-temperature-grown thin-film samples[29]. In contrast, for the sample grown at 100 °C, the value of  $M_S$  at 300 K is only  $\sim 0.2 \mu_B/\text{f.u.}$  due to formation of the  $A2$  structure in the films[26, 28, 29]. Figure 3(b) shows the values of  $M_S$  at 30 and 300 K versus  $T_g$  for the  $\text{Mn}_2\text{VAl}$  films. The values of  $S_{L2_1}$  and  $M_S$  for bulk[25] and thin-film[26, 28, 29]  $\text{Mn}_2\text{VAl}$  are summarized in Table I. While high  $T_g$  above 500 °C is typically required to obtain high  $S_{L2_1}$  and  $M_S$  values[25, 29], relatively high  $S_{L2_1}$  and  $M_S$  values are obtained at 350 °C in our MBE conditions. However, while the values of  $S_{B2}$  and  $S_{L2_1}$  in our 350 °C-grown films are  $\sim 1$  and  $\sim 0.7$ , the value of  $M_S$  remains 60% of the theoretical value[14]. As described later, the chemical composition of the  $\text{Mn}_2\text{VAl}$  layer on  $\text{MgO}(001)$  is almost stoichiometric, so that we expect that influence of excess V atoms in our  $\text{Mn}_2\text{VAl}$  films on the reduction in  $M_S$  is small. Although the  $D0_3$ -type disorder also affects the value of  $M_S$  in  $\text{Mn}_2\text{VAl}$ , it is generally difficult to quantitatively evaluate the degree of the  $D0_3$  disordering from a conventional XRD apparatus. At present, although there is still room to improve the  $S_{L2_1}$  and  $M_S$  values in our  $\text{Mn}_2\text{VAl}$  films, the results indicate the potential for the low-temperature synthesis of thin-film  $\text{Mn}_2\text{VAl}$  with high  $S_{L2_1}$  and high  $M_S$  under the as-grown conditions.



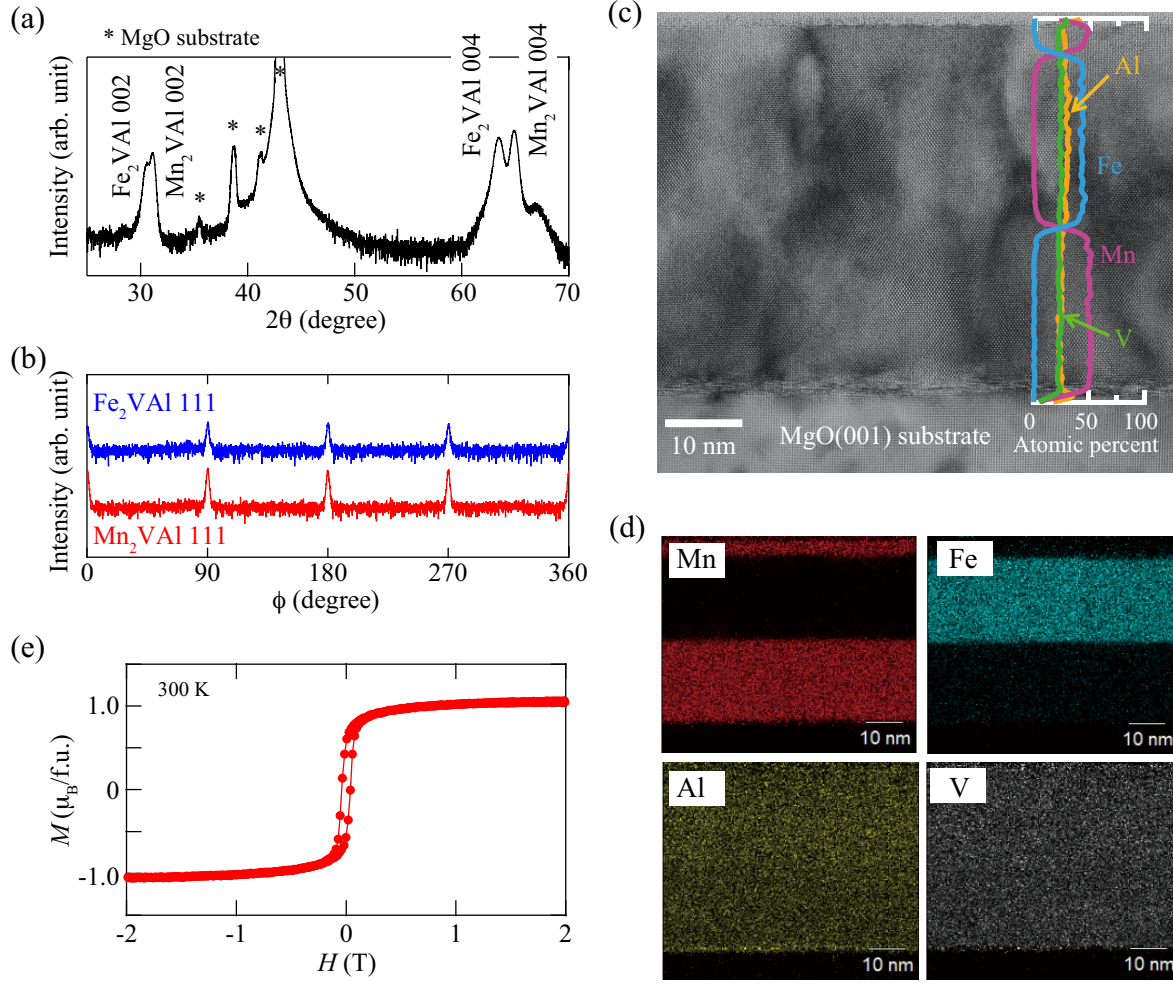


Figure 4: (Color online) (a) XRD profiles by  $\omega$ - $2\theta$  scan for a  $\text{Mn}_2\text{VAl}/\text{Fe}_2\text{VAl}/\text{Mn}_2\text{VAl}$  trilayer on  $\text{MgO}(001)$ . (b) XRD  $\phi$ -scan measurement of the (111) plane of  $\text{Fe}_2\text{VAl}$  (blue) and  $\text{Mn}_2\text{VAl}$  (red) for trilayer. (c) HAADF-STEM image and EDX line profiles for the trilayer. (d) EDX elemental maps of the region shown in (c). (e) In-plane  $M$ - $H$  curve measured at 300 K for the trilayer.

Finally, we attempted to grow a  $\text{Mn}_2\text{VAl}/\text{Fe}_2\text{VAl}/\text{Mn}_2\text{VAl}$  trilayer on a  $\text{MgO}(001)$  substrate, where  $L2_1$ -ordered  $\text{Fe}_2\text{VAl}$  is a well-known nonmagnetic Heusler alloy[39, 50]. The thicknesses of the top- $\text{Mn}_2\text{VAl}$ ,  $\text{Fe}_2\text{VAl}$  spacer, and bottom- $\text{Mn}_2\text{VAl}$  layers were  $\sim 15$ ,  $\sim 20$ , and  $\sim 25$  nm, respectively. During the growth of the trilayer, the substrate temperature was fixed to be  $350^\circ\text{C}$  and we did not perform post-annealing after the growth of each layer. The detailed growth conditions for the  $\text{Fe}_2\text{VAl}$  spacer layer are given in our previous studies[39, 40, 51]. After the growth of each layer, symmetrical streaks, which indicate two-dimensional epitaxial growth, were observed. Figure 4(a) shows an XRD profile by  $\omega$ - $2\theta$  scan for the  $\text{Mn}_2\text{VAl}/\text{Fe}_2\text{VAl}/\text{Mn}_2\text{VAl}$  trilayer on  $\text{MgO}(001)$ . 002 and 004 diffraction peaks of  $\text{Mn}_2\text{VAl}$  and  $\text{Fe}_2\text{VAl}$  are observed. From the  $\phi$ -scan measurements of the (111) plane of  $\text{Mn}_2\text{VAl}$  and  $\text{Fe}_2\text{VAl}$  shown in Fig. 4(b), we can confirm the presence of  $L2_1$ -ordered structures in the  $\text{Mn}_2\text{VAl}$  and  $\text{Fe}_2\text{VAl}$  layers.

Figure 4(c) shows a HAADF-STEM image and EDX line profiles for the  $\text{Mn}_2\text{VAl}/\text{Fe}_2\text{VAl}/\text{Mn}_2\text{VAl}$  trilayer on  $\text{MgO}(001)$ . The interfaces among the top  $\text{Mn}_2\text{VAl}$ ,  $\text{Fe}_2\text{VAl}$  spacer, and bottom  $\text{Mn}_2\text{VAl}$  layers cannot be identified from the HAADF-STEM image. From the EDX line profiles, the chemical composition along the stacking direction is abruptly changed at  $\sim 25$  and  $\sim 40$  nm from the  $\text{MgO}(001)$  substrate. For the bottom  $\text{Mn}_2\text{VAl}$  layer, the chemical composition is confirmed to be stoichiometric ( $\text{Mn}:\text{V}:\text{Al} = 2:1:1$ ), even though we used nonstoichiometric deposition conditions. Although the actual chemical composition in the  $\text{Fe}_2\text{VAl}$  spacer layer ( $\text{Fe}:\text{V}:\text{Al} = 1.8:1.0:1.2$ ) and top- $\text{Mn}_2\text{VAl}$  layer ( $\text{Mn}:\text{V}:\text{Al} = 1.8:1.0:1.2$ ) slightly deviates from the stoichiometry, no atomic interdiffusion is evident from the EDX elemental maps shown in Fig. 4(d). From the HAADF-STEM image in Fig. 4(c), the presence of an  $L2_1$ -ordered structure in each Heusler-alloy layer is confirmed.

An in-plane  $M$ - $H$  curve at 300 K for the trilayer is shown in Fig. 4(e), where the magnetic field was applied along  $[110]$  direction of  $\text{Mn}_2\text{VAl}$ . Here we assume that the  $\text{Fe}_2\text{VAl}$  spacer layer is nonmagnetic because the values of  $M_S$  for highly ordered epitaxial  $\text{Fe}_2\text{VAl}$  films are negligible small[39, 52]. The value

of  $M_S$  for the  $\text{Mn}_2\text{VAl}$  layers in the trilayer is estimated to be  $\sim 1.1 \mu_B/\text{f.u.}$ , which is equivalent to that for the single  $\text{Mn}_2\text{VAl}$  layer shown in Fig. 3(a). We speculate that the slight reduction in  $M_S$  from Fig. 3(a) is caused by the Al-rich composition in the top- $\text{Mn}_2\text{VAl}$  layer.

We have determined that epitaxial  $\text{Mn}_2\text{VAl}$  films with a relatively high  $S_{L2_1}$  can be obtained by MBE at a low  $T_g$  of 350 °C. It is noted that the values of  $S_{B2}$  and  $S_{L2_1}$  for the epitaxial  $\text{Mn}_2\text{VAl}$  films in this study were almost equivalent to those for the epitaxial  $\text{Fe}_2\text{VAl}$  films reported in our previous studies[39, 40]. Although there is only a difference in constituent elements at the (A,C) sites between  $L2_1\text{-Mn}_2\text{VAl}$  and  $L2_1\text{-Fe}_2\text{VAl}$ , the value of  $S_{B2}$  was  $\sim 1$  for both the  $\text{Mn}_2\text{VAl}$  and  $\text{Fe}_2\text{VAl}$  films. This indicates that the low-temperature MBE enables the suppression of  $\text{Mn} \leftrightarrow \text{V}$  disordering or  $\text{Fe} \leftrightarrow \text{V}$  disordering during growth. As a result, we have achieved an all-Heusler stack with  $L2_1$ -ordered structures and the sharp heterointerfaces shown in Fig. 4(c).

While many theoretical studies on the electronic band structures and magnetic properties of all-Heusler stacks have been reported[19, 53–64], there has only been a few experimental studies[45, 46, 65, 66]. In particular, for the emergence of unique physical properties expected theoretically, it is necessary to precisely control the structural ordering in not only the bulk region but also the interfacial region of all-Heusler stacks. From the structural characterization and magnetic property measurements, we have confirmed that there is still room to improve the structural characteristics of the all-Heusler stack shown in Fig. 4(c). To realize high-performance CPP-GMR devices due to the band symmetry and Fermi surface matching[19, 67, 68], improvement of the crystal quality of the trilayer and reduction of the  $\text{Fe}_2\text{VAl}$  spacer layer thickness should be investigated.

#### 4. Conclusion

We have studied the structural and magnetic properties of epitaxial  $\text{Mn}_2\text{VAl}$  films grown by MBE. The MBE technique enabled epitaxial  $\text{Mn}_2\text{VAl}$  films with

relatively high  $S_{L2_1}$  and  $M_S$  values to be grown at a  $T_g$  of 350 °C. These  $S_{L2_1}$  and  $M_S$  values were comparable to those for high-temperature-grown thin-film samples reported previously. Due to the low-temperature synthesis of  $L2_1$ - $Mn_2VAl$ , an all-epitaxial  $L2_1$ - $Mn_2VAl/L2_1$ - $Fe_2VAl/L2_1$ - $Mn_2VAl$  trilayer with sharp heterointerfaces, where  $Mn_2VAl/Fe_2VAl$  junctions are theoretically expected to exhibit high magnetoresistive properties, was obtained.

## 5. Acknowledgments

This work was supported in part by JSPS KAKENHI Grant Numbers 19H05616, 20J10124, the Nippon Sheet Glass Foundation for Materials Science and Engineering, the Hitachi Metals and Materials Science Foundation, and the Spintronics Research Network of Japan (Spin-RNJ).

## References

- [1] F. Heusler, Verh. Dtsch. Phys. Ges. 12 (1903) 219.
- [2] K. Manna, Y. Sun, L. Muechler, J. Kübler, and C. Felser, Nat. Rev. Mater. 3 (2018) 244.
- [3] K. Elphick, W. Frost, M. Samiepour, T. Kubota, K. Takanashi, H. Sukegawa, S. Mitani and, A. Hirohata, Sci. Technol. Adv. Mater. 22 (2020) 235.
- [4] Y. Sakuraba, M. Hattori, M. Oogane, Y. Ando, H. Kato, A. Sakuma, T. Miyazaki, H. Kubota, Appl. Phys. Lett. 88 (2006) 192508.
- [5] R. Shan, H. Sukegawa, W. H. Wang, M. Kodzuka, T. Furubayashi, T. Ohkubo, S. Mitani, K. Inomata, and K. Hono, Phys. Rev. Lett. 102 (2009) 246601.
- [6] K. Yakushiji, K. Saito, S. Mitani, and K. Takanashi, Y. K. Takahashi and K. Hono, Appl. Phys. Lett. 88 (2006) 222504.

- [7] T. Furubayashi, K. Kodama, H. Sukegawa, Y. K. Takahashi, K. Inomata, and K. Hono, *Appl. Phys. Lett.* 93 (2008) 122507.
- [8] T. A. Peterson, S. J. Patel, C. C. Geppert, K. D. Christie, A. Rath, D. Pennachio, M. E. Flatté, P. M. Voyles, C. J. Palmstrøm, and P. A. Crowell, *Phys. Rev. B* 94 (2009) 235309.
- [9] P. Bruski, Y. Manzke, R. Farshchi, O. Brandt, J. Herfort, and M. Ramsteiner, *Appl. Phys. Lett.* 103 (2013) 052406.
- [10] Y. Fujita, M. Yamada, M. Tsukahara, T. Oka, S. Yamada, T. Kanashima, K. Sawano, and K. Hamaya, *Phys. Rev. Applied* 8 (2017) 014007.
- [11] M. Yamada, F. Kuroda, M. Tsukahara, S. Yamada, T. Fukushima, K. Sawano, T. Oguchi, and K. Hamaya, *NPG Asia Mater.* 12 (2020) 47.
- [12] K. Kudo, M. Yamada, S. Honda, Y. Wagatsuma, S. Yamada, K. Sawano, and K. Hamaya, *Appl. Phys. Lett.* 118 (2021) 162404.
- [13] R. Weht and W. E. Pickett, *Phys. Rev. B* 60 (1999) 13006.
- [14] I. Galanakis, P. H. Dederichs, and N. Papanikolaou, *Phys. Rev. B* 66 (2002) 174429.
- [15] B. Balke, G. H. Fecher, H. C. Kandpal, C. Felser, K. Kobayashi, E. Ikenaga, J.-J. Kim, and S. Ueda, *Phys. Rev. B* 74 (2005) 104405.
- [16] S. Wurmehl, G. H. Fecher, H. C. Kandpal, V. Ksenofontov, C. Felser, H.-J. Lin, and J. Morais, *Phys. Rev. B* 72 (2005) 184434.
- [17] J. C. Slonczewski, *J. Magn. Magn. Mater.* 159 (1996) L1.
- [18] Y. Yoshida, M. Kawakami, and T. Nakamichi, *J. Phys. Soc. Jpn.* 50 (1981) 2203.
- [19] F. Kuroda, Ph. D. Thesis, Osaka University, 2020.
- [20] H. Itoh, T. Nakamichi, Y. Yamaguchi, and N. Kazama, *Trans. Jpn. Inst. Metals* 24 (1983) 265.

- [21] C. Jiang, M. Venkatesan, J.M.D. Coey, Solid State Commun. 118 (2001) 513.
- [22] J. Karel, F. Bernardi, C. Wang, R. Stinshoff, N.-O. Born, S. Ouardi, U. Burkhardt, G. H. Fecher and C. Felser, Phys. Chem. Chem. Phys. 17 (2015) 31707.
- [23] B. Deka, A. Srinivasan, R. K. Singh, B.S.D.Ch.S.Varaprasad, Y.K. Takahashi, and K. Hono, J. Alloys Compd. 662 (2016) 510.
- [24] K. Nagai, H. Fujiwara, H. Aratani, S. Fujioka, H. Yomosa, Y. Nakatani, T. Kiss, A. Sekiyama, F. Kuroda, H. Fujii, T. Oguchi, A. Tanaka, J. Miyawaki, Y. Harada, Y. Takeda, Y. Saitoh, S. Suga, and R. Y. Umetsu, Phys. Rev. B 97 (2018) 035143.
- [25] R. Y. Umetsu, H. Fujiwara, K. Nagai, Y. Nakatani, M. Kawada, A. Sekiyama, F. Kuroda, H. Fujii, T. Oguchi, Y. Harada, J. Miyawaki, and S. Suga, Phys. Rev. B. 99 (2019) 134414.
- [26] T. Kubota, K. Kodama, T. Nakamura, Y. Sakuraba, M. Oogane, K. Takanashi, and Y. Ando, Appl. Phys. Lett. 95 (2009) 222503.
- [27] T. Kubota, K. Kodama, T. Nakamura, Y. Sakuraba, M. Oogane, H. Naganuma, K. Takanashi, and Y. Ando, J. Magn. Soc. Jpn., 34 (2010) 100-106.
- [28] M. Meinert, J-M. Schmalhorst, G. Reiss, and E. Arenholz, J. Phys. D: Appl. Phys. 44 (2011) 215003.
- [29] K. Fukuda, M. Oogane, and Y. Ando, IEEE Trans. Magn. 53 (2017) 2600304.
- [30] T. Tsuchiya, R. Kobayashi, T. Kubota, K. Saito, K. Ono, T. Ohhara, A. Nakao, and K. Takanashi, J. Phys. D: Appl. Phys. 51 (2018) 065001.
- [31] T. Kubota, Y. Shimada, T. Tsuchiya, T. Yoshikawa, K. Ito. Y. Takeda, Y. Saitoh, T. J. Konno, A. Kimura, and K. Takanashi, Nanomaterials, 11 (2021) 1723.

- [32] T. Tsuchiya, J. Okabayashi, and S. Mizukami, *J. Magn. Magn. Mater.* 540 (2021) 168437.
- [33] K. Hamaya, H. Itoh, O. Nakatsuka, K. Ueda, K. Yamamoto, M. Itakura, T. Taniyama, T. Ono, and M. Miyao, *Phys. Rev. Lett.* 102 (2009) 137204.
- [34] S. Yamada, K. Hamaya, K. Yamamoto, T. Murakami, K. Mibu, and M. Miyao, *Appl. Phys. Lett.* 96 (2010) 082511.
- [35] K. Kasahara, K. Yamamoto, S. Yamada, T. Murakami, K. Hamaya, K. Mibu, and M. Miyao, *J. Appl. Phys.* 107 (2010) 09B105.
- [36] K. Hamaya, T. Murakami, S. Yamada, K. Mibu, and M. Miyao, *Phys. Rev. B* 83 (2011) 144411.
- [37] S. Yamada, J. Sagar, S. Honda, L. Lari, G. Takemoto, H. Itoh, A. Hirohata, K. Mibu, M. Miyao, and K. Hamaya, *Phys. Rev. B* 86 (2012) 174406.
- [38] S. Yamada, K. Tanikawa, S. Oki, M. Kawano, M. Miyao and K. Hamaya, *Appl. Phys. Lett.* 105 (2014) 071601.
- [39] S. Yamada, K. Kudo, R. Okuhata, J. Chikada, Y. Nakamura, and K. Hamaya, *Appl. Phys. Express* 10 (2017) 115802.
- [40] K. Kudo, S. Yamada, J. Chikada, Y. Shimanuki, T. Ishibe, S. Abo, H. Miyazaki, Y. Nishino, Y. Nakamura, and K. Hamaya, *Phys. Rev. B* 99 (2019) 054201.
- [41] K. Kudo, Y. Hamazaki, S. Yamada, S. Abo, Y. Gohda, and K. Hamaya, *ACS Appl. Electron. Mater.* 1 (2019) 2371.
- [42] Y. Shimanuki, S. Yamada, A. Masago, T. Ishibe, K. Kudo, Y. Nakamura, and K. Hamaya, *Phys. Rev. B* 102 (2020) 054203.
- [43] K. Kudo, S. Yamada, M. Yafuso, T. Kimura, V. K. Lazarov, and K. Hamaya, *J. Alloys Compd.* 854 (2021) 155571.

- [44] K. Kudo, A. Masago, S. Yamada, L. S. R. Kumara, H. Tajiri, Y. Sakuraba, K. Hono, and K. Hamaya, Phys. Rev. B 103 (2021) 104427.
- [45] S. Oki, S. Yamada, K. Tanikawa, K. Yamasaki, M. Miyao, and K. Hamaya, Appl. Phys. Lett. 103 (2013) 212402.
- [46] S. Yamada, S. Honda, J. Hirayama, M. Kawano, K. Santo, K. Tanikawa, T. Kanashima, H. Itoh, and K. Hamaya, Phys. Rev. B 94 (2016) 094435.
- [47] S. Yamada, S. Kobayashi, F. Kuroda, K. Kudo, S. Abo, T. Fukushima, T. Oguchi, and K. Hamaya, Phys. Rev. Mater. 2 (2018) 124403.
- [48] Y. Takamura, R. Nakane, and S. Sugahara, J. Appl. Phys. 105 (2009) 07B109.
- [49] Y. Takamura, T. Suzuki, Y. Fujino, and S. Nakagawa, J. Appl. Phys. 115 (2014) 17C732.
- [50] Y. Nishino, M. Kato, S. Asano, K. Soda, M. Hayasaki, and U. Mizutani, Phys. Rev. Lett. 79 (1997) 1909.
- [51] K. Kudo, S. Yamada, J. Chikada, Y. Shimanuki, Y. Nakamura, and K. Hamaya, Jpn. J. Appl. Phys. 57 (2018) 040306.
- [52] T. Kubota, M. Oogane, S. Mizukami, H. Naganuma, Y. Ando and T. Miyazaki, J. Phys.: Conf. Ser. 266 (2011) 012096.
- [53] K. Nikolaev, P. Kolbo, T. Pokhil, X. Peng, Y. Chen, T. Ambrose, and O. Mryasov, Appl. Phys. Lett. 94 (2009) 222501.
- [54] V. Ko, G. Han, J. Qiu and Y. P. Feng, Appl. Phys. Lett. 95 (2009) 202502.
- [55] V. Ko, G. Han, and Y. P. Feng, J. Magn. Magn. Mater. 322 (2010) 2989.
- [56] S. Chadov, T. Graf, K. Chadova, X. Dai, F. Casper, G. H. Fecher, and C. Felser, Phys. Rev. Lett. 107 (2011) 047202.
- [57] V. Ko, J. Qiu, P. Luo, G. C. Han, Y. P. Feng. J. Appl. Phys. 109 (2011) 07B103 (2011).



- [58] Z. Q. Bai, Y. H. Lu, L. Shen, V. Ko, G. C. Han, and Y. P. Feng, J. Appl. Phys. 111 (2012) 093911.
- [59] Z. Q. Bai, Y. Cai, L. Shen, G. C. Han, and Y. P. Feng, Appl. Phys. Lett. 102 (2013) 152403.
- [60] I. Di Marco, A. Held, S. Keshavarz, Y. O. Kvashnin, and L. Chioncel, Phys. Rev. B 97 (2018) 035105.
- [61] E. Şaşıoğlu, T. Aull, D. Kutschabsky, S. Blügel, and I. Mertig, Phys. Rev. Applied 14 (2020) 014082.
- [62] I. Galanakis, Phys. Status Solidi RRL 15 (2021) 2100139.
- [63] T. Aull, E. Şaşıoğlu, and I. Mertig, Appl. Phys. Lett. 118 (2021) 052405.
- [64] B. Pradines, L. Calmels, and R. Arras, Phys. Rev. Applied 15 (2021) 034009.
- [65] R. Knut, P. Svedlindh, O. Mryasov, K. Gunnarsson, P. Warnicke, D. A. Arena, M. Björck, A. J. C. Dennison, A. Sahoo, S. Mukherjee, D. D. Sarma, S. Granroth, M. Gorgoi, and O. Karis, Phys. Rev. B 88 (2013) 134407.
- [66] T. L. Brown-Heft, J. A. Logan, A. P. McFadden, C. Guillemard, P. Le Fèvre, F. Bertran, S. Andrieu, and C. J. Palmstrøm, Phys. Rev. Mater. 2 (2018) 034402.
- [67] S. Yabuuchi, I. Kitagawa, and T. Hamada, Extended Abstract of the 2010 International Conference on Solid State Devices and Materials, F-6-3, p.1120-1121.
- [68] S. Yabuuchi and I. Kitagawa, Jpn. J. Appl. Phys. **53** (2014) 093004.